

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

APPLICANT(S): Junichi Sato, et al. DOCKET NO.: 09792909-5921
SERIAL NO.: 10/828,882 GROUP ART UNIT: 2813
DATE FILED: April 21, 2004 EXAMINER: Laura M. Schillinger
INVENTION: SEMICONDUCTOR THIN FILM AND METHOD OF FABRICATING
SEMICONDUCTOR THIN FILM, APPARATUS FOR FABRICATING
SINGLE CRYSTAL SEMICONDUCTOR THIN FILM, AND METHOD OF
FABRICATING SINGLE CRYSTAL THIN FILM, SINGLE CRYSTAL
THIN FILM SUBSTRATE, AND SEMICONDUCTOR DEVICE

Commissioner for Patents
P. O. Box 1450
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S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. Copies of U.S. and foreign references and machine translations are attached.

Respectfully submitted by,

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